



1765  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Dmitri V. Vezenor, et al.

Serial No.: 09/842,214

Title: METHOD OF FABRICATING SUB-MICRON  
HEMISPHERICAL AND HEMICYLIDRICAL STRUCTURES  
FROM NON-SPHERICALLY SHAPED TEMPLATES

Filed: April 25, 2001

Attorney Docket No.: 1496.00379

Examiner: Ahmed, S.

Art Unit: 1765

In Response To: Office Action mailed June 10, 2004

I hereby certify that this letter, the response or amendment attached hereto are being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 7, 2004.

By: Jan M. Dunbar  
Jan M. Dunbar

**RESPONSE TO ELECTION/RESTRICTION REQUIREMENT**  
**UNDER 35 U.S.C. §121**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**IN THE SPECIFICATION**

Please replace the paragraph beginning at page 1, line 7  
with the following paragraph: